fluid comprising an ozone-containing gas and ultra pure water are sprayed onto substrates or semiconductor wafers in a treating chamber filled with ozone gas."

IN THE CLAIMS:

Please cancel claim 40 without prejudice.

Please amend claim 27 as follows:

27.   (Twice Amended) A method for removing organic contaminants from a substrate, comprising the steps of:

contacting at least one side of said substrate with a liquid comprising water, ozone and an additive acting as a scavenger, wherein the proportion of said additive in said liquid is less than 1% molar weight of said liquid; and

maintaining said liquid at a temperature less than the boiling point of said liquid.

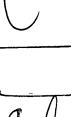Please add the following claims 51-60:

--51.   A method for removing organic contaminants from a substrate, comprising the steps of:

contacting at least one side of said substrate with a liquid comprising water, ozone and an additive acting as a scavenger, wherein said liquid is comprised substantially of water; and

maintaining said liquid at a temperature less than the boiling point of said liquid.

52.   A method as recited in claim 51, wherein the proportion of said additive in said liquid is less than 1% molar weight of said liquid.

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53. A method according to claim 52, wherein the proportion of said additive in said liquid is less than 0.1% molar weight of said liquid.

54. A method as recited in claim 51, wherein the temperature of said liquid is between 60°C and 80°C.

55. A method as recited in claim 51, wherein said liquid is subjected to megasone agitation.

56. A method as recited in claim 51, wherein the ozone is bubbled through the liquid.

57. A method as recited in claim 51, wherein said additive is acting as OH radical scavenger.

58. A method as recited in claim 51, further comprising the step of rinsing said substrate with a solution.

59. A method as recited in claim 58, wherein said solution comprises de-ionised water.

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